

a 4.8m cylindrical deflector (4.8mCD in Fig.1a). The position and width of the beam is monitored by five beam profile monitors (BPM) in optimum places of the beam line, and adjusted by quadrupole lenses (QL in Fig.1a) and steerers (XY in Fig.1a). The octopole electrode (SW) at the injection port of the LHD vacuum vessel sweeps the beam in order to scan plasma cross sections. Three-dimensional sweep and the active trajectory control method are accepted in order to manage complicated trajectory. The secondary beam created by charge exchange through the electron impact in the plasma is introduced into the tandem type energy analyzer.

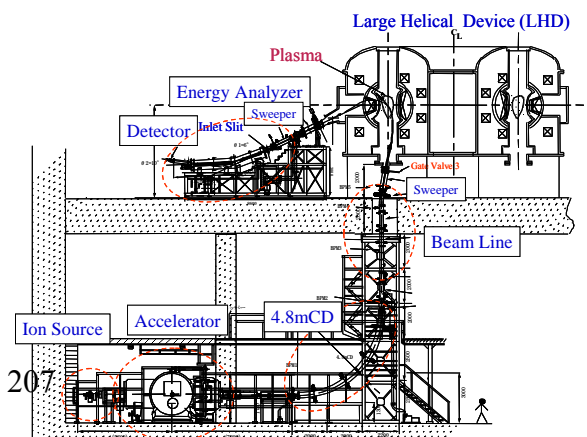
b

Fig.1. 6MeV HIBP System(a). Installation of 6MeV HIBP System

2.2 IMPROVEMENT OF ACCELERATOR

a

The 3MV tandem accelerator is used for obtaining 6MeV ion beam. The material of the accelerator tank was changed from iron to stainless steel at the installation into LHD hall in order not to disturb the LHD magnetic field in 2000 year. Operation of the accelerator was allowed after taking a license from the administrator in 2002. In starting aging, the amount of load current of the accelerator abnormally increased at voltages larger than 1MV as shown in Fig. 2. It is found from the observation of inner tank that abnormal current is caused by corona discharge between a high voltage terminal and tank edges. The corona discharge is shown in Fig.3 that is the photograph taken to determine the position where the corona discharge occurs. In the photograph, the inner wall of the tank illuminated by a light for 4 seconds and the corona discharge with exposure time of 16 minutes are superimposed. The surface of the inner wall of the accelerator tank is so rough that the corona discharge occurs even in SF₆ gas. The lode current was recovered by



polishing the tank wall near the terminal.

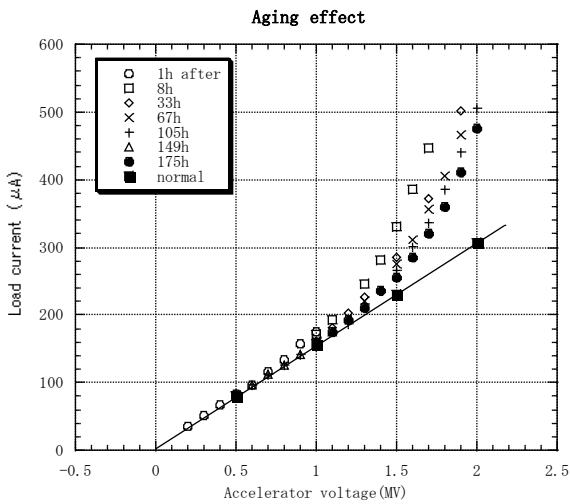


Fig.2. Load current of tandem accelerator

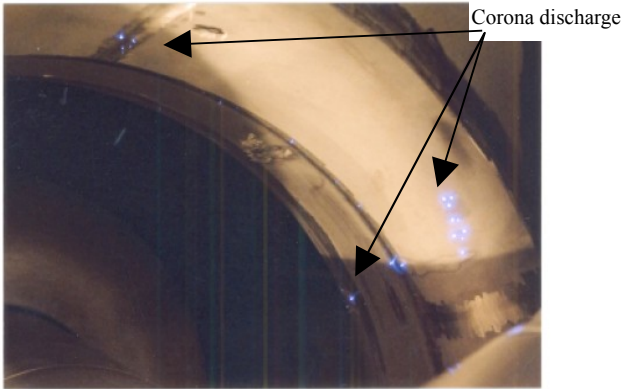


Fig.3. Corona discharge on the accelerator tank wall

2.3 PROBLEM IN THE BEAM LINE

The cylindrical electrostatic deflector with the radius of 4.8 m (4.8m CD) is divided into four sections to adjust the beam trace easily. The gap between the anode and the cathode is 30mm and curvature is large in order to treat the high voltage easily. The voltage applied to the electrodes is $\pm 40\text{kV}$ for a 6MeV beam. The leakage current increases yearly because of a lot of dust. The dust

may fall from upper devices such as LHD and beam line components or may be sputtered by the heavy ion beam with the energy of up to 6MeV. The cleaning of the gap dramatically reduces the leakage current as shown in the Table. The leak currents after the cleaning flow outside vacuum vessel at each electrode.

The beam adjustment to the injection port of LHD is influenced by leak filed of LHD. The displacement of the beam trajectory is compensated with the electrostatic steers.

A 7.8° cylindrical deflector (7.8°CD in Fig.1a and 4) is installed near the LHD injection port in order to bend the beam in the direction to the port. Applied voltage of 40kV requires for 6MeV beam. The magnetic field of LHD of 2 T or more causes the increase in the deflector current and the applied voltage goes down. The leakage field strength is a few hundred gauss and the direction is parallel to the electric field between the electrodes. The magnetic field line is perpendicular to the electric field between the electrodes and the grounded vacuum vessel of 7.8, and that may induce the discharge. The deflector is being developed and tested now.

Result of leak current improvement of 4.8m CD

stage	V(kV)	Before cleaning		After cleaning	
		+plate (μA)	-plate (μA)	+plate (μA)	-plate (μA)
1	40	101	113	0	0
2	40	164	166	2	27
3	40	110	114	7	0
4	40	35	16	28	3

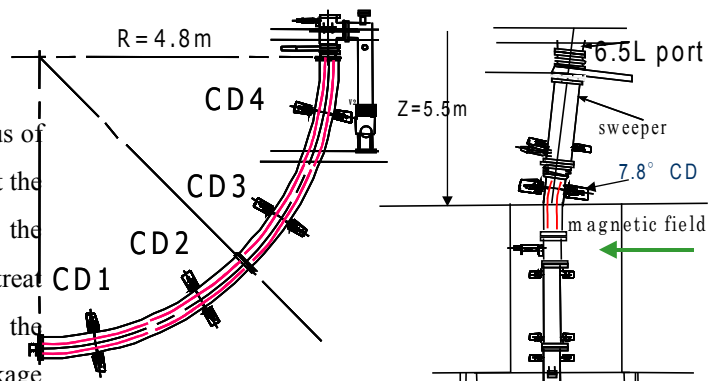


Fig.4. 4.8m and 7.8°cylindrical deflectors

2.4 ION SOURCE

The ion source with high output current and long lifetime is requested for the plasma diagnostic system. Especially, the high output current is required for the LHD plasmas because the large attenuation along the long beam path in plasma and beam line. In LHD-HIBP, ion source is a plasma sputter type of negative gold ion source, the maximum current is 12μA . A week operation under 8 hour per day is capable and depends on Cesium (Cs) quantity in the oven.

2.5 TANDEM TYPE ENERGY ANALYZER

The applied voltage of an electrostatic parallel plate energy analyzer with the incidence angle of 30 degree, which is popularly used in many scientific fields, is required about 1MV for the 6MeV HIBP. That is not realistic. A new tandem type analyzer [6] is proposed for solving this problem. As shown in figure 5, this analyzer is composed of combined two set electrostatic parallel plate analyzer and has second-order focus. Accepted incidence angle of a first and second stage are 6 and 10 degree, respectively. The applied voltages of first and second stage for the secondary beam of 6MeV are 50kV and 100kV, respectively. The characters of produced instrumentation in the factory were tested with 100keV thallium ion beam on the test stand. In figure 6, measured characteristics of dependence on incidence angle of normal deferece (ND), which is corresponding to potential change, is shown. Those are deferent from

calculation value for wide range angle. Distance from an exit port of LHD to detector point is long and the incidence angle variation is only 0.25 degree. Calibration results show that the produced analyzer can sufficiently apply for measurement of energy deference of determined beam energy because the flat curve in the range of 0.5 degree at the center energy.

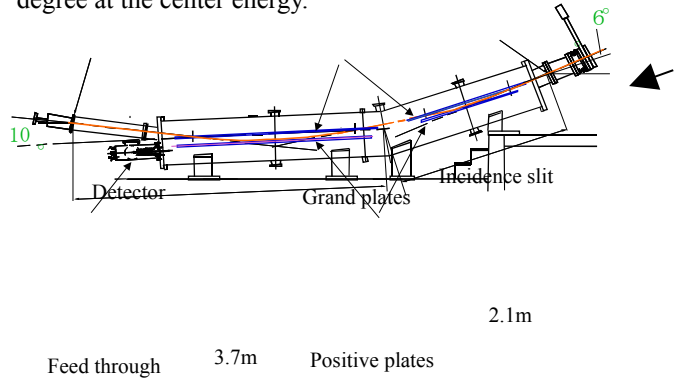
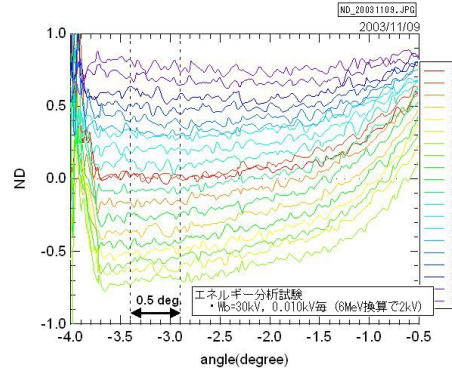


Fig 5 Configuration of tandem type energy analyzer



Wb<30kV, 0.01kV/d (2kV/d at 6MeV)

Fig. 6. Characteristics of tandem type energy analyzer

3. BEAM TRAJECTORY MEASUREMENTS

Beam trajectory in the helical field is more complicate than in tokomak field. A slight displacement in the beam injection angle into analyzer gives a significant error to potential measurements. Secondary beam sweep system is

introduced in addition to the primary sweep, and a set synchronized sweep is used for desirable observation position of the secondary ions birth. Therefore, trajectory calibration of primary beam is required to obtain precise event positions.

Primary beam is introduced to the LHD vacuum vessel in the magnetic field by the octpole sweeper and is detected by detectors installed on vacuum vessel wall. The sweeper axis is set on the direction where the beam crosses axis of the LHD vacuum vessel without applied voltage of the sweeper. As shown in figure 7, detector is composed of four stainless steel plates. V1 and V5 waveforms correspond to two dimensional sweep voltages in the injection sweeper. During the 2-D sweep the primary beam moves in the directions on the detector as shown with arrows in the fig.7. The beam is observed under the condition with the expected magnetic field strength and beam energy. The sweep voltage where the beam is observed is different from the expected value. It may be due to the error in the position of the detector or the beam line.

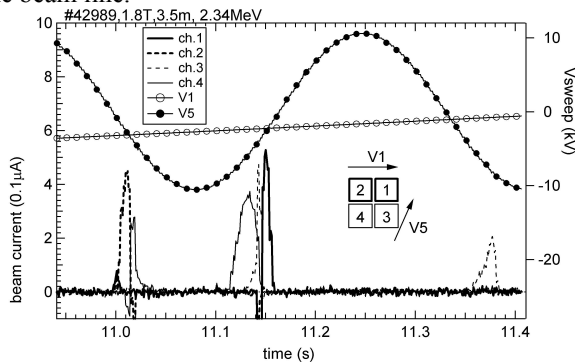


Fig. 7. Primary beam detection for trajectory check

4. CONCLUSIONS

The 6MeV HIBP, which is the biggest in HIBP systems, has been constructed for measurement of the LHD plasma. Some improvements on the large scaled HIBP have been done. Particularly, it is shown that new type tandem analyzer can be applied for analyzing energy at small incidence angle. The beam trajectory is tested with primary beam detectors in the magnetic field of LHD. The beam is observed under the condition with the expected magnetic field strength and beam energy.

One of the difficult problems is the discharge in 7.8°C/D in the magnetic field. The deflector is being improved.

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СОЗДАНИЕ ДИАГНОСТИЧЕСКОГО ПУЧКА ИОНОВ С ЭНЕРГИЕЙ 6 МЭВ ДЛЯ УСТАНОВКИ LHD

А. Нишизава, Т. Идо, Я. Хамада, С. Като, Я. Кавасуми, К. Цукадо, Е. Асано, М. Нишиура, А. Шимизу

6 МэВ-й источник ионов для измерений потенциала и плотности плазмы, а также их флуктуаций создаётся на установке LHD. За прошлый год завершено сооружение системы и улучшена работа системы при больших рассеянных магнитных полях LHD. Прохождение первичного пучка может наблюдаться с помощью детекторов, помещённых в вакуумную камеру, и тем самым подтвердить расчётные траектории в магнитном поле LHD.

СТВОРЕННЯ ДІАГНОСТИЧНОГО ПУЧКА ІОНІВ З ЕНЕРГІЄЮ 6 МЭВ ДЛЯ УСТАНОВКИ LHD

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6 МэВ джерело іонів для вимірів потенціалу і щільності плазми, а також їхніх флуктуацій створюється на установці LHD. За минулий рік завершено спорудження системи і поліпшена робота системи при великих розсіяних магнітних полях LHD. Проходження первинного пучка може спостерігатися за допомогою детекторів, поміщених у вакуумну камеру, і тим самим підтвердити розрахункові траєкторії в магнітному полі LHD.